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35C.14179



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Examiner: Not Yet Assigned YOUICHI ANDO, ET AL. Group Art Unit: Unassigned Application No.: 09/722,454 Filed: November 28, 2000 For: METHOD FOR MANUFACTURING ELECTRON BEAM DEVICE, METHOD FOR MANUFACTURING) IMAGE FORMING APPARATUS, ELECTRON BEAM DEVICE AND IMAGE FORMING APPARATUS MANUFACTURED THOSE MANUFACTURING METHODS, METHOD AND APPARATUS FOR MANUFACTURING ELECTRON SOURCE AND APPARATUS FOR) MANUFACTURING IMAGE FORMING APPARATUS March 14, 2001

Assistant Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-English documents is found on the specification where they are cited, in an abstract attached thereto and/or in a corresponding U.S. Patent. CONCLUSION It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. correspondence should continue to be directed to our address given below.

Respectfully submitted,

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